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Attorney Docket: 021906-0307405
Client Reference: PIA31178/DBE/US-HO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of LEE

Confirmation Number: 9617

Application No.: 10/743,454

Group Art Unit: 2823

Filed: December 23, 2003

Examiner: ESTRADA, MICHELLE

Title: METHOD FOR PLANARIZING A SURFACE OF A SEMICONDUCTOR WAFER

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.116

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Sir:

In response to the Final Office Action dated December 22, 2005, the date for responding being extended by one month to April 24, 2006 (Monday) by the corresponding petition and fee, please consider the following remarks in connection with the above-identified application: